
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mieher et al.

Attorney Docket No.: KLA1P119/1158

Application No.: 10/760,149

Examiner: Valentin, Juan D.

Filed: January 17, 2004

Group: 2877

Title: METHOD FOR PROCESS OPTIMIZATION
AND CONTROL BY COMPARISON BETWEEN 2 OR
MORE MEASURED SCATTEROMETRY SIGNALS

Confirmation: 7190

CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the
Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on **January 14, 2008**.

Signed: /Mary Deauclaire/
Mary Deauclaire

COMMUNICATION
Regarding Consideration of Previously Cited References

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon receiving the Notice of Allowance, we reviewed the 1449 forms to ensure that all references were signed off by the Examiner. When we discovered that all references were not signed off, my secretary contacted you. In a telephone conversation with my secretary, you had indicated that the reason for not signing off on these references was that dates were not provided for those particular references in the previously filed IDS filed on December 22, 2006. At that time, you asked that we submit those references again and include dates.

The Applicants submit the references again, with dates, in the attached Information Disclosure Statement and Form 1449. Also attached are copies of the non-US patent references cited in the Information Disclosure Statement.

We request that you consider and sign off on the remainder of the references, based upon the citations that now include dates.

Respectfully submitted,
BEYER WEAVER LLP

/Eric Yoon/
Eric Yoon
Reg. No. 60,611

/Mary R. Olynick/
Mary R. Olynick
Reg. No. 42,963

P.O. Box 70250
Oakland, CA 94612-0250